



<b>INFORMATION DISCLOSURE STATEMENT BY APPLICANT PTO-1449</b>	Docket No. <b>52433/847</b>	Application No. <b>10/578,218</b>	
	Applicant(s) <b>Katsuhiro SASAI et al.</b>	Examiner <b>ZHU, WEIPING</b>	
	Filing Date <b>May 3, 2006</b>	Confirmation No. <b>8373</b>	Art Unit <b>1793</b>

**U. S. PATENT DOCUMENTS**

EXAMINER INITIAL	PATENT/PUBLICATION NUMBER	PATENT/PUBLICATION DATE mm/dd/yyyy	NAME	CLASS	SUBCLASS	FILING DATE

**FOREIGN PATENT DOCUMENTS**

EXAMINER INITIAL	DOCUMENT NUMBER	DATE mm/dd/yyyy	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
						Yes	No

**OTHER DOCUMENTS**

EXAMINER INITIAL	AUTHOR, TITLE, DATE, PERTINENT PAGES, ETC.
/W.Z./	Kachiro SAIKI, "Effect of Annealing Condition on Deep Drawability of Cold Reduced Annealed Sheet" Journal of the Japan Society for Technology of Plasticity, Vol. 9. No. 85 (1968-2)

EXAMINER	/Weiping Zhu/	DATE CONSIDERED	05/27/2010
EXAMINER: Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.			